

Docket Number: 081468-0305146

Client Reference: P-1585.000-US



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of ANTONIUS JOHANNES  
VAN DER NET, et al.

Group Art Unit: 2851

Application No.: 10/623,180

Examiner: Rodney E. Fuller

Filed: July 21, 2003

Confirmation No.: 4722

For: LITHOGRAPHIC PROJECTION APPARATUS, GAS PURGING METHOD AND DEVICE  
MANUFACTURING METHOD AND PURGE GAS SUPPLY SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

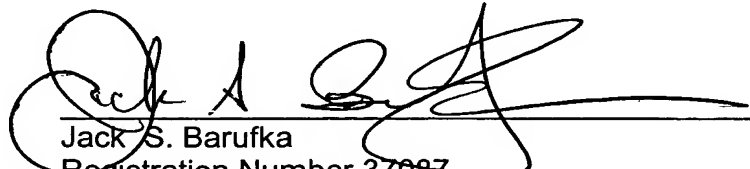
Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.

Respectfully Submitted,

PILLSBURY WINTHROP SHAW PITTMAN LLP



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Atty.  
Dkt. No.

M#

Client Ref.

0305146

P1585.000-US

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Applicant: VAN DER NET et al.

Appln. No.: 10/623,180

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Examiner: Rodney E. Fuller Group Art Unit: 2851

Date: November 6, 2006

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of

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**U.S. PATENT DOCUMENTS**

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR 2006/0118138 A1	06/08/2006	Spiegelman et al.			
	BR 2004/0238013 A1	12/02/2004	Spiegelman et al.			
	CR 2003/0162305 A1	08/28/2003	Alvarez, Jr. et al.			
	DR 2006/0211131 A1	09/21/2006	Spiegelman et al.			
	ER 6,638,341 B1	10/28/2003	Spiegelman et al.			
	FR 6,913,654 B2	07/05/2005	Alvarez, Jr. et al.			
	GR 6,391,09 B1	05/21/2002	Alvarez, Jr. et al.			
	HR 6,059,859 A	05/09/2000	Alvarez, Jr. et al.			
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	JR 5,910,292 A	06/08/1999	Alvarez, Jr. et al.			
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	LR 7,113,254 B2	09/26/2006	Van Der Net et al.			
	MR					
	NR					

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
	OR							
	PR							
	QR							
	RR							
	SR							
	TR							
	UR							
	VR							
	WR							
	XR							

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

	YR			
	ZR			
	AAR			
	BBR			
	CCR			
	DDR			

Examiner

Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.